



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

OKU et al

Serial No.: 09/903,764

Filed: July 13, 2001

For: FILM FORMING METHOD, SEMICONDUCTOR  
DEVICE AND SEMICONDUCTOR DEVICE  
MANUFACTURING METHOD

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) Examiner: Dang, T.

)  
) Art Unit: 2823  
)  
)  
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TECHNICAL STAFF 2800

PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

It is respectfully requested that the time period for filing a response to the office action of October 24, 2002, initially set to expire January 24, 2003, be extended two months up to and including March 24, 2003. The requisite \$410.00 fee for the requested extension is herewith attached.

Any additional fees may be charged to Deposit Account No. 12-2174.

Respectfully submitted,

George A. Loud  
Reg. No. 25,814

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410.00 OP

Date: March 24, 2003

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